



AF/DPW
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PATENT
Customer No. 22,852
Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Junji SUGAMOTO et al.) Group Art Unit: 2891
)
Application No.: 10/706,090) Examiner: LEE, Granvill D.
)
Filed: November 13, 2003)
)
For: SEMICONDUCTOR WAFER) Confirmation No.: 7292
TREATMENT METHOD,)
SEMICONDUCTOR WAFER)
INSPECTION METHOD,)
SEMICONDUCTOR DEVICE)
DEVELOPMENT METHOD AND)
SEMICONDUCTOR WAFER)
TREATMENT APPARATUS)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants petition for a third month extension of time to reply to the Office Action of March 23, 2005. A fee of \$570.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

09/23/2005 JADD01 00000022 10706090

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570.00 OP

Dated: September 22, 2005

By:

Richard V. Burgujian
Reg. No. 31,744